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3. In the drawings, any words are not translated.

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CLAIMS

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[Claim(s)]

[Claim 1] Lay a substrate on a flat table, move a die coating machine relatively to this substrate, and it faces [ applying on the above-mentioned substrate, and ]. Form a range-measurement machine in the above-mentioned die coating machine, and the real gap of the above-mentioned die coating machine and a substrate is measured beforehand in all application regions. The method of application of the die coating machine characterized by applying making it go up and down the above-mentioned die coating machine to a substrate based on this operation value at the time of an application after calculating the deflection of the above-mentioned real gap and a criteria gap in all these application regions.

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[Translation done.]